

## Electronic Acknowledgement Receipt

<b>EFS ID:</b>	1086797
<b>Application Number:</b>	10555141
<b>Confirmation Number:</b>	2898
<b>Title of Invention:</b>	Method for texturing surfaces of silicon wafers
<b>First Named Inventor:</b>	Alexander Hauser
<b>Customer Number:</b>	832
<b>Filer:</b>	Anthony Niewyk/Michelle Davis
<b>Filer Authorized By:</b>	Anthony Niewyk
<b>Attorney Docket Number:</b>	RAC0082
<b>Receipt Date:</b>	21-JUN-2006
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<b>Application Type:</b>	U.S. National Stage under 35 USC 371
<b>International Application Number:</b>	

### Payment information:

Submitted with Payment	no
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### File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1	Amendment - After Non-Final Rejection	RAC0082AMEND.pdf	101834	no	5

<b>Warnings:</b>	
<b>Information:</b>	
<b>Total Files Size (in bytes):</b>	101834
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<b><u>New Applications Under 35 U.S.C. 111</u></b> If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.	
<b><u>National Stage of an International Application under 35 U.S.C. 371</u></b> If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.	